

Abstract Submitted  
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**Resistive all boron carbide neutron detectors**<sup>1</sup> ELLEN DAY, MANUEL DIAZ, CAROLINA ILIE, SHIREEN ADENWALLA, Mechanical Engr., Physics and Astronomy and CMRA, Univ. of Nebraska-Lincoln — Semiconducting boron carbide is a promising material for true solid-state neutron detection [1]. An all boron carbide (BC) layer was deposited on sapphire ( $\text{Al}_2\text{O}_3$ ) with sputtered Chrome/Gold electrical contacts. Resistance vs. temperature measurements indicate a  $T^{-3/2}$  dependence and a band gap of  $\sim 0.17\text{eV}$ . X-ray diffraction measurements confirm the similarities in crystal structure of the films grown on  $\text{Al}_2\text{O}_3$  and Si. Detection area ranged from  $0.25\text{mm}^2$  to  $1\text{mm}^2$  and the thickness of the films ranged from 280nm to 600nm. Neutron detection measurements show no sharp spectral peaks but a long high energy tail which increased in counts as the reactor power was increased, in agreement with both monte carlo simulations and simple model calculations [2]. The low thermal neutron capture cross section of Al and O ensures that the entire neutron signal observed is from the resistive boron carbide layer, thus demonstrating the fabrication of an all boron carbide neutron detector. We show plots as a function of reactor power and thickness. [1] B.W. Robertson, S. Adenwalla, A. Harken, et al., *Appl. Phys. Lett.* **80**, 3644 (2002). [2] C. Lundstedt, A. Harken, E. Day, B. W. Robertson, S. Adenwalla, submitted to NIM.

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